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""(b) The role of stress on intrinsic and extrinsic contributions to piezoelectric response, dielectric, and mechanical response """"(c) Domain wall contributions to performance ""; "" (d) Other contributions to performance and performance attributes ""; ""(e) Investigation and modeling of stress profile as a function of device geometry ""; ""(f) Limitations in modeling associated with linear mechanical and piezoelectric behavior ""; ""(g) Device reliability and lifetime ""; ""IV. APPLICATIONS ""; ""V. FUTURE DIRECTIONS ""; ""ACKNOWLEDGMENTS ""; ""REFERENCES""
""PIEZOELECTRIC MATERIALS: STRUCTURE, PROPERTIES AND APPLICATIONS """"ABSTRACT""; ""I. TREND OF CERAMIC ACTUATOR ""; ""1. Trend of Ceramic Actuator ""; ""2. An Overview of Solid-State Actuator and High Strain Piezoelectric Actuator Structure ""; ""II. NEW TYPE ACTUATOR FABRICATED BY POWDER INJECTION MOLDING ""; ""1. New Type Piezoelectric Transformer: Manufacturing Process, Structure and Properties of Dome Shaped Piezo-Tansformer ""; ""1.1 Introduction ""; ""1.2 Manufacturing process""
""1.3 Characteristic the effects of geometrical factors on the step-up ratio in piezoelectric transformer ""